(19) World Intellectual Property Organization International Bureau





(43) International Publication Date 15 May 2003 (15.05.2003)

PCT

(10) International Publication Number WO 03/041133 A3

(51) International Patent Classification⁷: H01L 21/00

(21) International Application Number: PCT/US02/36009

(22) International Filing Date:

8 November 2002 (08.11.2002)

(25) Filing Language: English

(26) Publication Language: English

(30) Priority Data:

60/337,527	9 November 2001 (09.11.2001)	US
60/337,528	9 November 2001 (09.11.2001)	US
60/337,529	9 November 2001 (09.11.2001)	US
60/338,055	9 November 2001 (09.11.2001)	US
60/338,069	9 November 2001 (09.11.2001)	US
60/338,072	9 November 2001 (09.11.2001)	US

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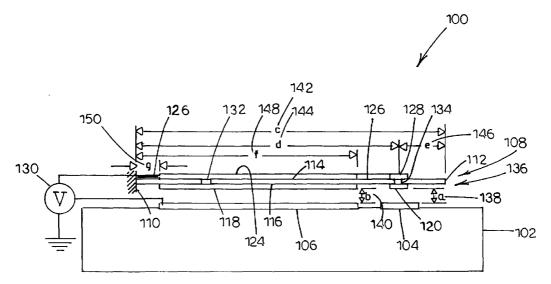
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- (81) Designated States (national): AE, AG, AL, AM, AT, AU, AZ, BA, BB, BG, BR, BY, BZ, CA, CH, CN, CO, CR, CU, CZ, DE, DK, DM, DZ, EC, EE, ES, FI, GB, GD, GE, GH, GM, HR, HU, ID, IL, IN, IS, JP, KE, KG, KP, KR, KZ, LC, LK, LR, LS, LT, LU, LV, MA, MD, MG, MK, MN, MW, MX, MZ, NO, NZ, OM, PH, PL, PT, RO, RU, SD, SE, SG, SI, SK, SL, TJ, TM, TN, TR, TT, TZ, UA, UG, US, UZ, VC, VN, YU, ZA, ZM, ZW.
- (84) Designated States (regional): ARIPO patent (GH, GM, KE, LS, MW, MZ, SD, SL, SZ, TZ, UG, ZM, ZW), Eurasian patent (AM, AZ, BY, KG, KZ, MD, RU, TJ, TM), European patent (AT, BE, BG, CH, CY, CZ, DE, DK, EE, ES, FI, FR, GB, GR, IE, IT, LU, MC, NL, PT, SE, SK, TR), OAPI patent (BF, BJ, CF, CG, CI, CM, GA, GN, GQ, GW, ML, MR, NE, SN, TD, TG).

[Continued on next page]

(54) Title: ELECTROTHERMAL SELF-LATCHING MEMS SWITCH AND METHOD



(57) Abstract: Electrothermal Self-Latching MEMS Switch and Method. According to one embodiment, a microscale switch (100) having a movable microcomponent (108) is provided and includes a substrate (102) having a stationary contact (104). The switch (100) can also include a structural layer (112) having a movable contact (108) positioned for contacting the stationary contact (104) when the structural layer (112) moves toward the substrate (102). Electrothermal latch (126) attached to the structural layer (112) and having electrical communication (114, 116) with the movable contact (108) to provide current flow between the electrothermal latch (126) and the stationary contact (104) when the movable contact (108) contacts the stationary contact (104) for maintaining the movable contact (108) in contact with the stationary contact (104).



WO 03/041133 A3



Published:

with international search report

(88) Date of publication of the international search report: 12 September 2003

For two-letter codes and other abbreviations, refer to the "Guidance Notes on Codes and Abbreviations" appearing at the beginning of each regular issue of the PCT Gazette.

INTERNATIONAL SEARCH REPORT

International application No.
PCT/US02/86009

A. CLASSIFICATION OF SUBJECT MATTER IPC(7) :H01L 21/00					
	:348/22, 23, 24, 30, 106, 108; 257/415, 418, 419				
According t	According to International Patent Classification (IPC) or to both national classification and IPC				
B. FIELDS SEARCHED					
Minimum d	ocumentation searched (classification system followed	d by classification symbols)			
U.S. : 348/22, 23, 24, 30, 106, 108; 257/415, 418, 419					
	tion searched other than minimum documentation to	the extent that such documents are in	ncluded in the fields		
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Electronic data base consulted during the international search (name of data base and, where practicable, search terms used)					
USPTO APS EAST					
search ter	search terms: micro electromechanical, electrothermal, stationary contact layer, movable contact layer				
C. DOCUMENTS CONSIDERED TO BE RELEVANT					
Category*	Citation of document, with indication, where ap	propriate, of the relevant passages	Relevant to claim No.		
Y,P	US 6,316,278 B1 (JACOBSEN et	al) 13 November 2001	1-28		
	(13.11.2001), see entire document.				
Y	US 5,824,186 A (SMITH et al) 20 October 1998 (20.10.1998), see 1-28				
	entire document.				
A	US 5,796,152 A (CARR et al) 18 Au	gust 1998 (18.08.1998), see	1-28		
	entire document.				
A,P	US 6,324,748 B1 (DHULER et al) 04 I	December 2001 (04.12.2001),	1-28		
	figures 5A-5C.				
Further documents are listed in the continuation of Box C.		C. See patent family annex.			
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		"&" document member of the same patent family			
Date of the	actual completion of the international search	Date of mailing of the international se	arch report		
18 JANUARY 2003		V4 AFR			
		Authorized officer			
Commissioner of Patents and Trademarks Box PCT Washington D.C. 90931		PHUC T. DANG			
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